

# The 19<sup>th</sup> U.S.–Korea Forum on Nanotechnology

---

## **President Heung Soo Park**

National NanoFab Center, Daejeon, Korea



Heung Soo Park is the President of National NanoFab Center (NNFC), located in the campus of Korea Advanced Institute of Science and Technology (KAIST), Daejeon, Republic of Korea. NNFC is the nation's largest semiconductor public R&D facility (including 5,000m<sup>2</sup> cleanroom) offering technology platform services to the industry, academia and R&D institutes in the areas of silicon-based semiconductor, MEMS-based sensors, Nano-Bio and Display while nurturing new technologies in house. It also provides semiconductor education courses for college students and graduates with in-house training programs, e.g. process and equipment training, as well as continuing education programs for semiconductor professionals in the industry.

Heng Soo Park has spent more than 30 years in the semiconductor field, mostly in the industry including Samsung Electronics (Korea), Texas Instruments (Dallas, Tx, USA) and DB Hitek (Korea). He was a research professor at Yonsei University, Seoul before joining NNFC as president. He graduated from Seoul National University with a BS and a MS degree in metallurgical engineering in 1983 and 1985, and obtained a Ph.D. degree in materials science and engineering from Stanford university in 1994.